

03500.103115

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: David G. Weisz
Satoru Nishiuma	)	
	:	Group Art Unit: 1797
Application No. 10/553,870	)	
	:	Confirmation No. 1107
Filed: October 21, 2005	)	
	:	
For: OPTICAL ANALYSIS DEVICE	)	August 5, 2009

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449.

Copies of the cited Japanese patent documents are enclosed. According to a commercial database, the cited Japanese patent documents correspond to the cited U.S.

Patent documents as follows:

Japanese Patent Pub. No.	U.S. Patent Nos.
11-505610	6,078,705; 6,289,144
2001-504230	6,198,869
2001-500959	6,211,954
61-191965	4,818,710

The fee for this Information Disclosure Statement is being paid electronically. Any deficiency in or overpayment of the fee should be charged or credited to Deposit Account No. 06-1205.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

/Donald H. Heckenberg, Jr./

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